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PATENT APPLICATION

#10/Amndt C
W. Lee
1/30/03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
NAOTO ABE ET AL.)
Application No.: 09/726,020)
Filed: November 30, 2000)
For: ELECTRON SOURCE APPARATUS)
AND IMAGE FORMING)
APPARATUS)
Examiner: W. Lee
Group Art Unit: 2821
January 13, 2003

Commissioner for Patents
Washington, D.C. 20231

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JAN 21 2003
TECHNOLOGY CENTER 2800

AMENDMENT, PETITION FOR EXTENSION OF TIME, AND REQUEST FOR
CONSIDERATION OF PREVIOUSLY CITED ART

Sir:

Applicant's petition to extend the time for response to the Office Action
(Paper No. 8) of September 11, 2002, to Saturday, January 11, 2003. A check in the
amount of \$110.00 in payment of the extension fee is enclosed. Please charge any
additional fee and credit any overpayment to our Deposit Account 06-1205.

I hereby certify that this correspondence is being deposited with the
United States Postal Service as first-class mail in an envelope
addressed to: Assistant Commissioner for Patents, Washington, D.C.
20231 on January 13, 2003.

(Date of Deposit)

01/17/2003 NMCHAMM1 00000204 09726020

01 FD:1251

110.00 0P

FRANK A. DeLUCIA

(Name of Attorney for Applicant)

Signature

January 13, 2003

Date of Signature